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No.3706 P. 2

Application No. 09/972,428

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NMTI 1002-4
(747 CON 2)

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I hereby certify that this correspondence is being facsimile
transmitted to Examiner John S. Ruggles, Art Unit 1756,
United States Patent and Trademark Office at Fax No. 703.872.9306 on 6 May 2004.

Kathryn Marley

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of inventor(s):
Christophe Pierrat et al.

Group Art Unit: 1756
Examiner: John S. Ruggles

Application No. 09/972,428

Confirmation No. 3974

Filing Date: 05 October 2001

Title: **Exposure Control for Phase
Shifting Photolithographic Masks**

CUSTOMER NO. 30437

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

RESPONSE TO FINAL OFFICE ACTION

Sir:

In response to the Final Office Action mailed 1 March 2004, Applicants request
the following amendments in the above-referenced application:

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks begin on page 9 of this paper.

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